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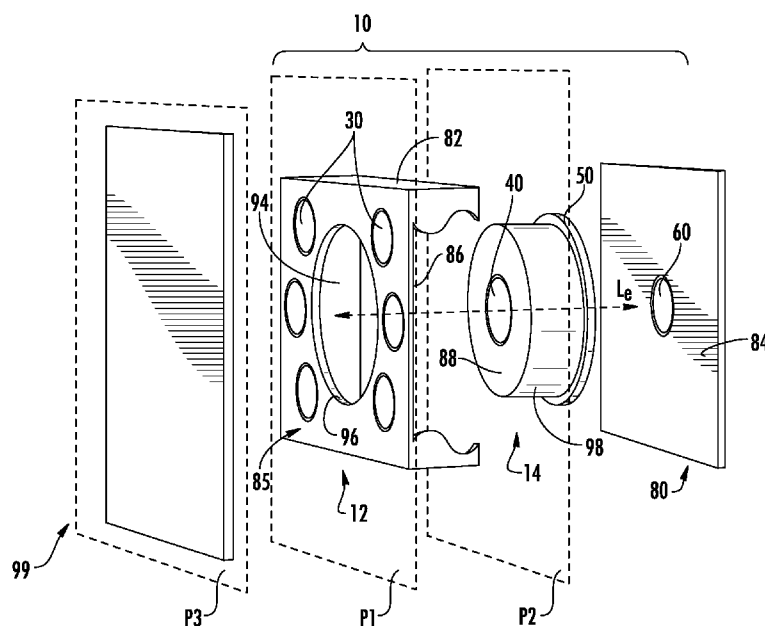
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(54) Title: MOUNTING APPARATUS

**FIG. 1**

(57) Abstract: A mounting apparatus and system and method for making the same are provided. The mounting apparatus allows an object to be mounted to a mounting surface via magnetic attractions between different planes of engagement. Through the movement of planes of magnets, an object that is brought in proximity to the mounting apparatus may engage one of the magnetic planes and then be moved further to engage the other magnetic plane, with the combined magnetic force being configured to support the particular object for which the mounting apparatus is designed. The engagement and/or disengagement of the object from the mounting apparatus can thus occur in stages, by degrees, and/or in a tiered manner.